

Form PTO-1449 U.S. Department of Commerce
Patent & Trademark Office

INFORMATION DISCLOSURE STATEMENT
(Use separate sheets if necessary)

Atty. Docket No.
2022/48640

Serial No.
09/544,558

Applicants
Cyprian Uzoh et al.

10/042,244

Filing Date
April 6, 2000

Group Art Unit
3723

31017 U.S. PTO
10/042244
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EXAMINER

Timothy V. Elzy

DATE CONSIDERED

08/23/01

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Initial if citation considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication.

Form PTO-1449 U.S. Department of Commerce
Patent & Trademark OfficeAtty. Docket No.
2022/48640Serial No.
09/544,558 10/042,244INFORMATION DISCLOSURE STATEMENT
(Use several sheets if necessary)

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Applicants
Cyprian Uzoh et al.Filing Date
April 6, 2000Group Art Unit
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Timothy V. Eley-Wheeler

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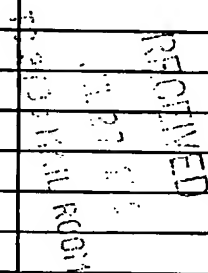
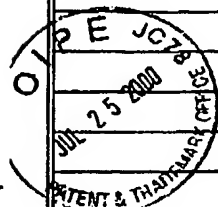
Timothy V. Eley Wheeler

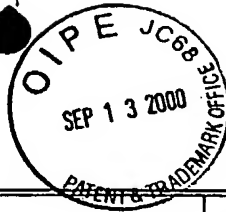
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Sheet 1 of 1

Form PTO-1449

U.S. Department of Commerce
Patent & Trademark OfficeAtty. Docket No.
2022/48640Serial No.
09/544,558 10/042,241Applicant
Cyprian Uzoh et al.Filing Date
April 6, 2000Group
3723**INFORMATION DISCLOSURE STATEMENT**
(Use several sheets if necessary)

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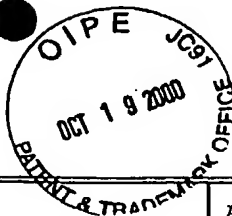
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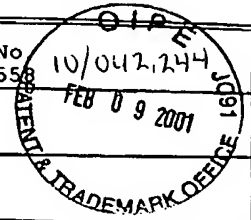


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| Form PTO-1449 | | U.S. Department of Commerce Patent & Trademark Office | | Atty. Docket No. 2022/48640 | | Serial No. 09/544,558 10/042,244 | |
| INFORMATION DISCLOSURE STATEMENT (Use several sheets if necessary) | | | | Applicant Cyprian Uzoh et al. | | | |
| | | | | Filing Date April 6, 2000 | | Group 3723 | |
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| Form PTO-1449 U.S. Department of Commerce Patent & Trademark Office INFORMATION DISCLOSURE STATEMENT (Use several sheets if necessary) | Atty. Docket No. 2022/48640 | Serial No. 09/544,558 |
| | Applicant Cyprian Uzoh et al. | |
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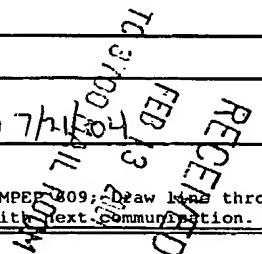


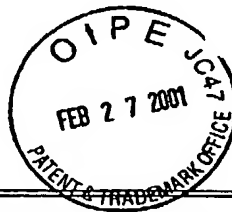
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| EXAMINER <i>Timothy K. Elg Wheadon</i> | DATE CONSIDERED <i>08/23/01</i> |
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Sheet 1 of 1

Form PTO-1449

U.S. Department of Commerce
Patent & Trademark OfficeAtty. Docket No.
2022/48640Serial No.
09/544,558 10/042,244Applicant
Cyprian Uzoh et al.Filing Date
April 6, 2000Group
3723**INFORMATION DISCLOSURE STATEMENT**
(Use several sheets if necessary)**U.S. PATENT DOCUMENTS**

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EXAMINER *Timothy V. Eley Wheeler*DATE CONSIDERED *08/23/01 7/21/04*

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| INFORMATION DISCLOSURE STATEMENT (Use several sheets if necessary) | | Applicant Cyprian Uzoh et al. | | | |
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